



BUREAU VERITAS

NISSIN ION EQUIPMENT CO., LTD.

4F GRAND KYOTO, 75 NISHIKUJO-HIGASHIHIEIJO-CHO, MINAMI-KU, KYOTO-CITY, KYOTO, 601-8438, JAPAN

This is a multi-site certificate, additional site(s) are listed on the next page(s)

Bureau Veritas Certification Holding SAS - UK Branch certifies that the Management System of the above organisation has been audited and found to be in accordance with the requirements of the management system standards detailed below

ISO 9001:2015

Scope of certification

- DESIGN, DEVELOPMENT AND MANUFACTURE OF
 - (1) ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR (I/I)
 - (2) ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR FPD (FPD)
- PROVISION OF ION IMPLANTATION SERVICES

| | |
|---|------------|
| Original cycle start date: | 11-11-1996 |
| Expiry date of previous cycle: | NA |
| Certification / Recertification Audit date: | 30-11-2023 |
| Certification / Recertification cycle start date: | 09-01-2024 |
| Subject to the continued satisfactory operation of the organisation's Management System, this certificate expires on: | 16-01-2027 |

Certificate No.: JP024338 Version: 1 Issue date: 09-01-2024



0008

Signed on behalf of BVCH SAS UK Branch

Certification Body Address: 5th Floor, 66 Prescott Street, London, E1 8HG, United Kingdom

Local Office: Bureau Veritas Japan Co., Ltd. Certification Division
KRC bldg. 8F, 18 Nihon-odori, Naka-ku, Yokohama, Japan 231-0021

Further clarifications regarding the scope and validity of this certificate, and the applicability of the management system requirements, please call: 045-651-4784



Bureau Veritas Certification



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NISSIN ION EQUIPMENT CO., LTD.

ISO 9001:2015

Scope of certification

| Site Name | Site Address | Site Scope |
|------------------------|---|--|
| TOJI OFFICE | 4F GRAND KYOTO, 75 NISHIKUJO-HIGASHIHIEIJO-CHO, MINAMI-KU, KYOTO-CITY, KYOTO, 601-8438, JAPAN | SALE OF ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR (I/I) AND SEMICONDUCTOR FPD (FPD) |
| KUZE PLANT | 575 KUZE-TONOSHIRO-CHO, MINAMI-KU, KYOTO-CITY, KYOTO, 601-8205, JAPAN | <ul style="list-style-type: none"> · DEVELOPMENT OF ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR (I/I) · PROVISION OF ION IMPLANTATION SERVICES |
| KYOTO LOGISTICS CENTER | 1 TAKADA, MORIMOTO-CHO, MUKO-CITY, KYOTO, 617-0003, JAPAN | LOGISTICS OF ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR (I/I) AND SEMICONDUCTOR FPD(FPD) |
| SHIGA PLANT | 29 HINOKIGAOKA, MINAKUCHI-CHO, KOKA-CITY, SHIGA, 528-0068, JAPAN | <ul style="list-style-type: none"> · DESIGN, DEVELOPMENT AND MANUFACTURE OF ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR (I/I) · DESIGN, DEVELOPMENT AND MANUFACTURE OF ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR FPD (FPD) |

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